

EAST Search History

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|-------|---|--------------------------------|------------------|---------|------------------|
| L2 | 176 | (silicon near2 substrate) and (LED with package) and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 15:30 |
| L4 | 855 | ("257"/\$.ccls. or "438"/\$.ccls.) and (LED) and (power with (w or watt))and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 15:32 |
| L5 | 48 | ("257"/\$.ccls. or "438"/\$.ccls.) and (LED.clm.) and (power with (w or watt))and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 15:32 |
| L6 | 2147 | 257/99,e33.056.ccls. | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:32 |
| L7 | 292 | (amoh-teruo or ishidu-sadamu or higaki-kenjiro or tsuzuki-yasushi or fukuda-hiroshi).inv. | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:33 |
| L8 | 5335 | (SUMITOMO ELECTRIC INDUSTRIES).as. | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:34 |
| L9 | 576 | 8 and packag\$3 | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:34 |
| L10 | 35 | 7 and packag\$3 | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:34 |
| L11 | 595 | 9 or 10 | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 16:35 |
| S1 | 38585 | (physical vapor deposition) or pvd | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:20 |
| S2 | 12598 | ((physical vapor deposition) or pvd) and (imager or LED or laser) | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:20 |
| S3 | 7557 | ((physical vapor deposition) or pvd) and (imager or LED or laser) and rate | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:25 |
| S4 | 39485 | ((physical vapor deposition) or pvd or (vacuum vapor deposition) or vvd or sputter or sputtering) and (imager or LED or laser) and rate | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:27 |
| S5 | 36632 | S4 and (aluminum or al) | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:26 |

EAST Search History

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|-----|------|---|--------------------------------|-----|-----|------------------|
| S6 | 7183 | ((physical vapor deposition) or pvd or (vacuum vapor deposition) or vvd or sputter or sputtering) and (imager or LED or laser) and rate and ("438"/\$).ccls. | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:28 |
| S8 | 133 | S7 and ((sputter\$3 near3 rate) or (arrival near2 rate) or (deposit near3 rate)) | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 09:32 |
| S9 | 3559 | ((physical vapor deposition) or pvd or (vacuum vapor deposition) or vvd or sputter or sputtering) and (imager or LED or laser) and rate and ("438"/\$).ccls. and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 10:01 |
| S10 | 9687 | ((physical vapor deposition) or pvd or (vacuum vapor deposition) or vvd or sputter or sputtering) and roughness and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 15:22 |
| S11 | 7788 | ((physical vapor deposition) or pvd or (vacuum vapor deposition) or vvd or sputter or sputtering) and (roughness near2 surface) and @pd<"20040222" | US-PGPUB; USPAT; IBM_TDB | ADJ | OFF | 2008/01/04 10:10 |
| S12 | 4 | "2004111616".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:13 |
| S13 | 1 | "6017226".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:13 |
| S14 | 2 | "06017226".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:16 |
| S15 | 2 | "07243027".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:18 |
| S16 | 3 | "2003209286".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:22 |
| S17 | 4 | "2004079750".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:25 |
| S18 | 4 | "2004071675".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:28 |
| S19 | 4 | "2005039194".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:32 |
| S20 | 2 | "09293904".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:33 |
| S21 | 1 | "6777720".pn. | US-PGPUB; USPAT | ADJ | OFF | 2008/01/04 10:36 |
| S22 | 3 | "2002232017".pn. | JPO; DERWENT | ADJ | OFF | 2008/01/04 10:37 |